

Benefits of tandem MS applied to elemental analysis Agilent 8900 ICP-MS/MS

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Agilent ICP-MS – Detection Limits (ng/L)

н				< à (0.1 n	g/L																	F	le
				0.10	à 1.0	0 ng/	L																	
Li	Be			1.0 à 10 ng/L B C N O F N												le								
0.19	0.08			> à 10 ng/L 2.9																				
Na	Mg	Stan	dard	nebul	izer,	Mode	He	ou N	loGas							ΑΙ		Si	Ρ		S	СІ	ŀ	٨r
3.3	0.27	integ * S a	ratio	n time : LD	e 3 se en µ	ec/ma g/L	sse,	n = 1	10 et 3	sig	ma					0.71	8	800	114	2	20*	4.6*		
K	Са	Sc	Ti	1	V	Cr	Μ	In	Fe	С	o	Ni	С	u	Zn	Ga		Ge	As	S	Se	Br	k	٢r
1100	48	0.67	1.9	0	14	0.99	0.	66	9.2	0.	14 1	.57	0.4	41 [·]	1.02	0.07	1	.13	0.41	6	5.4	34.8		
Rb	Sr	Υ	Zr	N	lb	Мо	Т	Ċ	Ru	R	h F	Pd	Α	g	Cd	In	5	Sn	Sb	1	Ге	T	Х	(e
0.12	0.04	0.01	0.04	0.	04	0.12	0.	12	0.11	0.	04 0	.11	0.0	08	0.08	0.03	0	.24	0.08	1.	.08	2.02		
Cs	Ba		Hf	Т	a	W	R	e	Os	1	r I	Pt	Α	u	Hg	ТІ	F	P b	Bi	P	0	At	R	n
0.06	0.22	LA	0.05	0 .	04	0.13	0.	04	0.29	0.	09 0	.09	0.1	17	0.18	9.08	0	.16	0.03					
Fr	Rd	• •		12	Co		Dr	N			Sm	E		Gd	т		ער	H		Er	Tm		'n	Lu
		AC		La 0.01	0.02	2 0,	.01	0.0	5 F		0.06	0.0	u)2	0.05	0.0		ע 0.07	0.0) [1 0.	_1 04	0.01		05	Lu 0.02
				_										-	-					• •	0.0			-
			4	Ac	Th	ר F	a	U	N	p	Pu	Ar	n	Cm	B	k	Cf	E	s F	m	Mc	A R	0	Lr
					0.0	3		0.0	2															



Spectrocopy Interferences

⁴⁵Sc

⁴⁷Ті ⁴⁹Ті ⁵⁰Ті

⁵¹V ⁵²Cr

⁵³Cr ⁵⁴Fe

⁵⁵Mr

⁵⁶Fe ⁵⁷Fe

⁵⁸Ni ⁵⁹Co

⁶⁰Ni

⁶¹Ni

⁶³Cu

⁶⁴Zn

⁶⁵Cu ⁶⁶Zn ⁶⁷Zn

⁶⁸Zn ⁶⁹Ga

⁷⁰Zn

⁷¹Ga
 ⁷²Ge
 ⁷³Ge
 ⁷⁴Ge
 ⁷⁵As
 ⁷⁷Se
 ⁷⁸Se
 ⁸⁰Se

Spectroscopy interferences arise from two primary sources:

Elemental presence

- Isobaric overlap of more than one element sharing a single nominal mass.
- **Doubly-charged species** (less frequent and usually of negligible impact).

Molecular species detected

 Polyatomic (molecular) species from matrix and gases.

ре	Principal Interfering Species (mixed matrix)										
	¹³ C ¹⁶ O ₂ , ¹² C ¹⁶ O ₂ H, ⁴⁴ CaH, ³² S ¹² CH, ³² S ¹³ C, ³³ S ¹² C										
	³¹ P ¹⁶ O, ⁴⁶ CaH, ³⁵ Cl ¹² C, ³² S ¹⁴ NH, ³³ S ¹⁴ N										
	³¹ P ¹⁸ O, ⁴⁸ CaH, ³⁵ Cl ¹⁴ N, ³⁷ Cl ¹² C, ³² S ¹⁶ OH, ³³ S ¹⁶ O										
	³⁴ S ¹⁶ O, ³² S ¹⁸ O, ³⁵ Cl ¹⁴ NH, ³⁷ Cl ¹² CH										
	³⁵ Cl ¹⁶ O, ³⁷ Cl ¹⁴ N, ³⁴ S ¹⁶ OH										
	³⁶ Ar ¹⁶ O, ⁴⁰ Ar ¹² C, ³⁵ Cl ¹⁶ OH, ³⁷ Cl ¹⁴ NH, ³⁴ S ¹⁸ O										
	³⁶ Ar ¹⁶ OH, ⁴⁰ Ar ¹³ C, ³⁷ Cl ¹⁶ O, ³⁵ Cl ¹⁸ O, ⁴⁰ Ar ¹² CH										
	⁴⁰ Ar ¹⁴ N, ⁴⁰ Ca ¹⁴ N, ²³ Na ³¹ P										
	³ [′] Cl ¹⁸ O, ²³ Na ³² S, ²³ Na ³¹ PH										
	⁴⁰ Ar ¹⁶ O, ⁴⁰ Ca ¹⁶ O										
	⁴⁰ Ar ¹⁶ OH, ⁴⁰ Ca ¹⁶ OH										
	⁴⁰ Ar ¹⁸ O, ⁴⁰ Ca ¹⁸ O, ²³ Na ³⁵ Cl										
	⁴⁰ Ar ¹⁸ OH, ⁴³ Ca ¹⁶ O, ²³ Na ³⁵ ClH										
	⁴⁴ Ca ¹⁶ O, ²³ Na ³⁷ Cl										
	⁴⁴ Ca ¹⁶ OH, ³⁸ Ar ²³ Na, ²³ Na ³⁷ ClH										
	$^{40}\text{Ar}^{23}\text{Na}$, $^{12}\text{C}^{10}\text{O}^{33}\text{Cl}$, $^{12}\text{C}^{14}\text{N}^{37}\text{Cl}$, $^{31}\text{P}^{32}\text{S}$, $^{31}\text{P}^{10}\text{O}_2$										
	³² S ¹⁶ O ₂ , ³² S ₂ , ³⁶ Ar ¹² C ¹⁶ O, ³⁸ Ar ¹² C ¹⁴ N, ⁴⁸ Ca ¹⁶ O										
	³² S ¹⁶ O ₂ H, ³² S ₂ H, ¹⁴ N ¹⁶ O ³⁵ CI, ⁴⁸ Ca ¹⁶ OH										
	³⁴ S ¹⁶ O ₂ , ³² S ³⁴ S, ³³ S ₂ , ⁴⁸ Ca ¹⁸ O										
	³² S ³⁴ SH, ³³ S ₂ H, ⁴⁸ Ca ¹⁸ OH, ¹⁴ N ¹⁶ O ³⁷ Cl, ¹⁶ O ₂ ³⁵ Cl										
	³² S ¹⁸ O ₂ , ³⁴ S ₂										
	³² S ¹⁸ O ₂ H, ³⁴ S ₂ H, ¹⁶ O ₂ ³⁷ Cl										
	³⁴ S ¹⁸ O ₂ , ³⁵ Cl ₂										
	³⁴ S ¹⁸ O ₂ H, ³⁵ Cl ₂ H, ⁴⁰ Ar ³¹ P										
	⁴⁰ Ar ³² S, ³⁵ Cl ³⁷ Cl, ⁴⁰ Ar ¹⁶ O ₂										
	⁴⁰ Ar ³² SH, ⁴⁰ Ar ³³ S, ³⁵ Cl ³⁷ ClH, ⁴⁰ Ar ¹⁶ O ₂ H										
	⁴⁰ Ar ³⁴ S, ³⁷ Cl ₂										
	⁴⁰ Ar ³⁴ SH, ⁴⁰ Ar ³⁵ Cl, ⁴⁰ Ca ³⁵ Cl, ³⁷ Cl ₂ H										
	⁴⁰ Ar ³⁷ Cl, ⁴⁰ Ca ³⁷ Cl										
	⁴⁰ Ar ³⁸ Ar										
	⁴⁰ Ar ₂ , ⁴⁰ Ca ₂ , ⁴⁰ Ar ⁴⁰ Ca, ³² S ₂ ¹⁶ O, ³² S ¹⁶ O ₃										



Collision and Reaction Cell (CRC) technology





Principle of He Mode and KED*





Blank Acid Matrices and IPA in No Gas Mode

Color of spectrum indicates which matrix gave each interfering peak



No Gas Mode



Blank Acid Matrices and IPA in He Mode

Color of spectrum indicates which matrix gave each interfering peak





Hydrogen Mode





Blank Acid Matrices and IPA in No Gas Mode

Color of spectrum indicates which matrix gave each interfering peak



No Gas Mode



Blank Acid Matrices and IPA in H2 Mode



H₂ Mode



Review of CRC ; Merit and Demerit of two Modes of Cell

	Collision Mode	Current Reaction Mode					
Gas	Helium	H_2 , NH_3 , CH_4 , O_2					
Mechanism	Difference in ion size (Universal)	Difference in chemical reaction (non Universal)					
DL improvement	1 - 5 orders	1 - 6 orders					
Ease of use	Easy – matrix independent	Difficult –matrix dependent					
Application	Widely used, multi- elemental capacity	Limited, element dependent					



Limitations of Reaction Mode in ICP-QMS

- Limitations of reactive cell gases in quadrupole ICP-MS are welldocumented:
 - All ions enter the cell, affecting reaction processes and product ions formed. Gives variable results when sample type/matrix or co-existing analytes change
 - Product ions from matrix or other elements can create new overlaps on analytes
 - Analyte product ions can be overlapped by other analytes/matrix elements
- Can tandem MS configuration (ICP-MS/MS) address the variability caused by co-existing elements and changing matrix components?



ICP-MS/MS: How Does it Work?



ICP (plasma) and Interface: Forms and extracts ions from the sample (just like ICP-QMS)



Q1 – controls ions that enter the cell

 Consistent reactions even if sample composition changes ORS⁴ – collision/ reaction gas added

101010-0

 lons react and are neutralized or moved

• Product ions are formed



Q2 – selects the target analyte mass
Interference-free analyte ions passed to EM

EM (detector): Measures the ions that pass through Q2 (just like ICP-QMS)





ICP-MS/MS: How Does it Work?



ICP (plasma) and Interface: Forms and extracts ions from the sample (just I Inique as)



Q1 – controls ions that enter the cell

 Consistent reactions even if sample composition changes Interface: ts ions from Unique aspect of 8900 is MS/MS Mode

- Q1 rejects ALL ions at masses other than target analyte precursor ion mass
 - All existing ions that could overlap an analyte product ion are removed
 - All existing ions that could form a product ion overlap at the analyte ion/product ion mass are removed
 - Only the analyte and on-mass interference(s) enter the cell

EM (detector): Measures the ions that pass through Q2 (just like ICP-QMS)





ICP-MS/MS 8900 : the Power of MS/MS









O₂ reaction gas













Q1 eliminates all off-mass species before they can enter the CRC This eliminates any reaction by-products before they form



8900 ICP-MS/MS – Multi-elemental technic

App note: 5991-6943EN

Table 3. Method detection limits.

Element	Scan Mode	01	02	DL (ppb)	Element	Scan Mode	01	02	DL (ppb)
В	Single Quad		11	0.3653	Se	Single Quad		78	0.3158
Na	Single Quad		23	0.1945	Se	MS/MS	78	94	0.0506
Mg	Single Quad		24	0.1235	Rb	Single Quad		85	0.0115
AI	Single Quad		27	0.1847	Sr	Single Quad		88	0.0006
Р	MS/MS	31	47	0.0919	Mo	Single Quad		95	0.0090
s	MS/MS	32	48	0.4367	Ag	Single Quad		107	0.0063
К	Single Quad		39	7.0656	Cd	Single Quad		111	0.0018
Са	Single Quad		44	8.7579	Sn	Single Quad		118	0.0074
V	Single Quad		51	0.0079	Sb	Single Quad		121	0.0026
Cr	Single Quad		52	0.0880	Ba	Single Quad		138	0.0008
Mn	Single Quad		55	0.0099	Hg	Single Quad		202	0.0005
Fe	Single Quad		56	0.1595	ТІ	Single Quad		205	0.0104
Co	Single Quad		59	0.0009	РЬ	Single Quad		208	0.0016
Ni	Single Quad		60	0.0484	Th	Single Quad		232	0.0018
Cu	Single Quad		63	0.0102	U	Single Quad		238	0.0009
Zn	Single Quad		66	0.0308					
As	Single Quad		75	0.0044					
As	MS/MS	75	91	0.0040					



Agilent 8900 ICP-QQQ for **SiO₂** NPs Unprecedented detection – not possible with ICP-QMS



Fast TRA of SiO₂ NPs – by far the most important engineered NPs (ENPs) in environment

Low Si background, high sensitivity and <u>effective control of interferences with MS/MS</u> ensure that small (50 nm) SiO₂ NPs can be easily distinguished from background signal



5991-6596EN

Response (cps)

SiO₂ Nanoparticle Reference Material Results



100 nm $\int_{100}^{100} \int_{100}^{100} \int_{100}$

100

Particle Size (nm)

150

200

50

0.

 Pranocomposit
 Background equivalent diameter ~ size detection limit – most likely limited by dissolved Si.



Which Applications benefit from ICP-QQQ?

Application data can demonstrate high value of Agilent 8900.

- Environmental: MoO/ZrOH overlap on Cd. REE⁺⁺ overlap As⁺ & Se⁺.
- High purity chemical: Ti and Zn analysis in semiconductor grade H_2SO_4/H_3PO_4 .
- Petro/organics S, Si (and Mg, Cr) in fuels; abundance sensitivity separates ¹¹B
- Material: P in Si matrix. SiH⁺ and SiH₂⁺ overlap on P⁺. Nanoparticles detection
- Metals: As in Co matrix. Fe and Ni in Ca matrix. MO⁺/MOH⁺ interference on Cd.
- Geology: Rb/Sr analysis, REE analysis. BaO and REE-O ion overlap other REE.
- Food: Sulfur Isotope Ratio analysis.
- Clinical: Ti and Cr analysis in blood and serum. S, P and C matrix.
- Nuclear: ¹²⁹Iodine analysis. ¹²⁹Xe atomic isobar interference,Long live nuclide analysis. ⁹³Zr, ⁹⁹Tc, ¹³⁵Cs, Ra 226, Np237, Pu239/240
- Life Science: Trace Sulfur for protein/peptide quantification, P for phosphorylation studies.
- Agilent Handbook of Application: **5991-2802**











Agilent 7800 ICP-MS

Agilent 7900 ICP-MS

Agilent 8900 ICP-000

QUESTIONS?

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